

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/674,388	TAKA ET AL.	
Examiner	Art Unit	
Eduarda Colon Sontana	2027	

	2					
SEARCHED						
Class	Subclass	Date	Examiner			
318	685, 696, 700, 714, 720, 721	2/17/2005	ECS			
	722-724					
	799-813					
		8				
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examine	
1				
-		_		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
,	DATE	EXMR			
EAST SEARCH plus TEXT SEARCH	2/16/2005	ECS			
SEARCH EPO, JPO AND DERWERT DATABASE	2/17/2005	ECS			
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